

All-Solid-State Electrochromic Multilayer System For Surface Heat Radiation Control

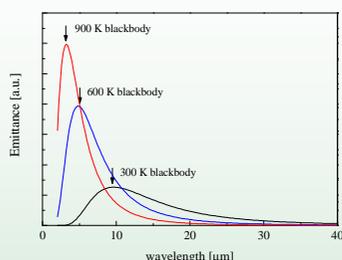
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Radiation Characteristics The blackbody spectrum



$$M(\lambda) = \frac{2\pi^5 h^2 c^2}{15} \times \frac{1}{\exp\left(\frac{hc}{\lambda kT}\right) - 1}$$

T ...temperature
 λ ...wavelength

Emissivity ϵ and Device Performance Parameters

$$e = \frac{\int_{\lambda_1}^{\lambda_2} [1 - R(\lambda)] M(\lambda, T) d\lambda}{\int_{\lambda_1}^{\lambda_2} M(\lambda, T) d\lambda}$$

R ...reflectance

M ...blackbody spectral emittance

Emissivity modulation

$$e_{modul.} = e_{high} - e_{low}$$

e_{high} ...emissivity in high emittance state

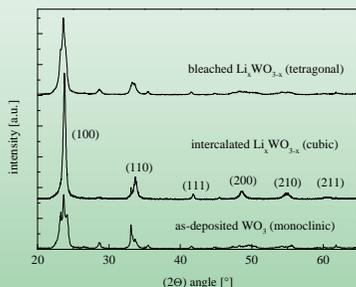
e_{low} ...emissivity in low emittance state

Emissivity ratio

$$e_{ratio} = \frac{e_{high}}{e_{low}}$$

General comments

- All films were grown by either r.f. or d.c. magnetron sputtering
- Electrochemical Li^+ intercalation performed in a 1M solution of LiClO_4 in propylene carbonate
- Irreversible phase transformation in polycrystalline WO_3 upon Li^+ intercalation and deintercalation



- Optical constants of intercalated and deintercalated single film device constituents were measured and analyzed using spectroscopic ellipsometry from 0.03 to 1 eV
- Experimentally measured optical constants of device constituents layers have been used for simulations of device performance

For details see:

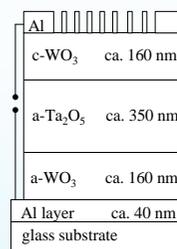
E. Franke et al., APL **77**, 930 (2000)

E. Franke et al., JAP **88**, 5777 (2000)

E. Franke et al., JAP **88**, 5166 (2000)

E. Franke et al., TSF **388**, 283 (2001)

Reflectance modulating single-grid electrochromic device



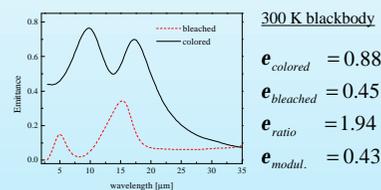
Note:

Devices were optimized and tested for application in the 300 K blackbody spectral region.

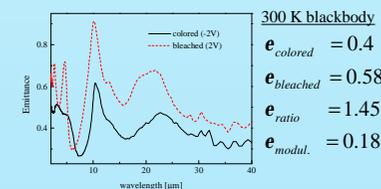
Legend:

a...amorphous
c...polycrystalline

Simulated device performance



Experimentally measured device performance

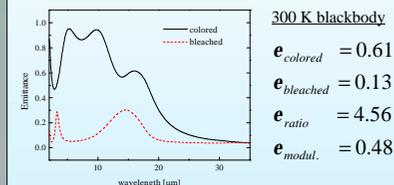


Single-grid device performance simulations

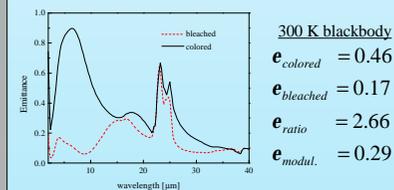
Purpose of cover layers:

- protect the polycrystalline WO_3 -layer
- prevent Li^+ chemical reactions
- prevent moisture incorporation
- act as an optical impedance match to improve switching performance

Simulated device performance with a 600 nm thick ZnSe cover



Simulated device performance with a 900 nm thick MgF_2 cover



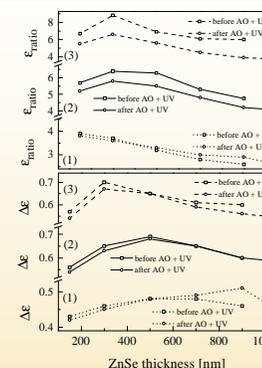
600 K blackbody

$e_{colored} = 0.65$
 $e_{bleached} = 0.13$
 $e_{ratio} = 4.88$
 $e_{modul.} = 0.52$

900 K blackbody

$e_{colored} = 0.62$
 $e_{bleached} = 0.12$
 $e_{ratio} = 5.2$
 $e_{modul.} = 0.50$

Emittance modulation and ratio as function of ZnSe thickness and temperature



-Stability of ZnSe single layers in atomic oxygen (AO) and during UV radiation was tested (simulation of low earth orbit conditions).

-Change in ZnSe optical constants during AO and UV treatment was used to simulate degradation effects for device performance

-ZnSe thickness was optimized for several environment temperatures [(1) 300K, (2) 600K, (3) 900K] to achieve best emittance modulation and ratio

Conclusions

- Operational all-solid-state electrochromic devices for thermal emittance modulation

- Single-grid device with opposite switching behavior than predicted by simulation, because of non-ideal Li^+ distribution (Li^+ trapped in interfaces, a certain Li^+ amount remains in the layer, which is supposed to be free according to the voltage polarity)

- Best experimental device performance for single-grid device

- Cover layer improves device switching behavior and reliability

- Atomic oxygen exposure and UV radiation cause degradation of the ZnSe layer, and therefore a change in emittance modulation and ratio of the device